NOTES:

1. SUBSTRATE:

**FUSED SILICA** 

2. COATING (APPLY ACROSS CLEAR APERTURE)

\$1: Ultrafast (1010-1110nm)

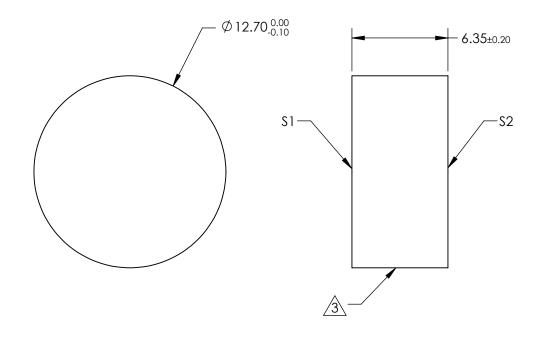
R(AVG) S&P > 99.90% @ 1060nm R(AVG) > 99.7% @ 1010 – 1110nm

GDD SPECIFICATION: ±20 fs2@ 1010 - 1100nm @ 45° AOI

S2: NONE



4. ROHS COMPLIANT



## FOR INFORMATION ONLY: DO NOT MANUFACTURE PARTS TO THIS DRAWING

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

	\$1	\$2			PI	Edmund Optic	C®
SHAPE	PLANO	PLANO					,S
SURFACE QUALITY	10 - 5	COMMERCIAL POLISH		1		Low-GDD Ultrafast Dielectric Mirror, 106	0nm
CLEAR APERTURE	Ø11.43	N/A	THIRD ANGLE PROJECTION		TITLE	45° AOI, 12.7mm Dia., 6.35mm Thick	
SURFACE FLATNESS	λ/8	N/A				40 /(O), 12./11111 Bld., 0.0011111 Tillek	CLIEFT
BEVEL	PROTECTED AS NEEDED	PROTECTED AS NEEDED	ALL DIMS IN	mm	DWG NO	26838	SHEET 16 OF 24